

<b>Notice of References Cited</b>		Application/Control No. 09/756,906	Applicant(s)/Patent Under Reexamination KENDALL ET AL.	
		Examiner Thu Thao Havan	Art Unit 3691	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0023404	09-2001	Ogawa et al.	705/4
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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